

262/Kmagl

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No. : 10/517,483
Applicant : KAULE
Filed : 12-10-2004
TC/A.U. :
Examiner : Unassigned

Docket No. : 2732-150
Customer No. : 06449
Confirmation No. : 6823

INFORMATION DISCLOSURE STATEMENT

Director of the United States Patent
and Trademark Office
P.O. Box 1450
Alexandria, Virginia 22313-1450

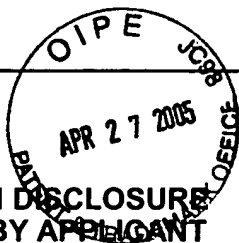
Dear Sir:

Under the provisions of 37 C.F.R. §§ 1.56, 1.97 and 1.98, Applicant submits herewith information that the Office may wish to consider in examination of the subject application. The publications are listed on the attached form PTO-1449.

Respectfully submitted,

By 

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Attorney for Applicants
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**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

Complete if Known

Application Number	10/517,483
Filing Date	12-10-2004
First Named Inventor	KAULE
Group Art Unit	
Examiner Name	
Confirmation No.	6823

Sheet

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of

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Attorney Docket Number 2732-150

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published	T ²
	1	RAI-CHOUDHURY XP- 002251881, SPIE Handbook for Microlithography, <i>Micromachining</i> and Microfabrication, Volume 1: Microlithography (pages 1-16, 2-fold)	

Examiner Signature		Date Considered	
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Unique citation designation number. ²Applicant is to place a check mark here if English language Translation is attached.